

<b>Notice of References Cited</b>	Application/Control No. 09/824,301	Applicant(s)/Patent Under Reexamination BODE ET AL.	
	Examiner Sean P. Shechtman	Art Unit 2125	Page 1 of 1

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	B	US-5,432,702 ✓	07-1995	Barnett	364/468
	C	US-6,442,445 ✓	08-2002	Bunkofske et al.	700/108
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#### NON-PATENT DOCUMENTS

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	U	Michael Quirk, "Semiconductor Manufacturing Technology" December 15 <sup>th</sup> 2000, Prentice Hall, 1 <sup>st</sup> edition.
	V	Fukuda, "Advanced Process Control Systems Description of an easy-to-use control system incorporating pluggable modules" 1999, IEEE.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.